

PATENT
BY COURIER

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Ritzdorf et al.
Application No. : 09/018,783 Confirmation No.:
Filed : August 31, 1999
For : METHOD AND APPARATUS FOR LOW TEMPERATURE
ANNEALING OF METALLIZATION MICRO-STRUCTURES
IN THE PRODUCTION OF A MICROELECTRONIC DEVICE

Examiner : G. Wyszomierski
Art Unit : 1742
Docket No. : 29195.8162US1
Date : October 1, 2001

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Commissioner for Patents
Washington, DC 20231

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97 through 1.98, applicants wish to make known to the Patent and Trademark Office the references set forth on the attached form PTO/SB/08A (copies of the cited references, as required under 37 C.F.R. § 1.98, are enclosed). Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicants' duty to disclose all information of which they are aware that is believed relevant to the patentability of the above-identified application, applicants believe that their invention is patentable. As to any document supplied, applicants do not admit that it is "prior art" under 35 U.S.C. §§ 102 or 103, and

specifically reserve the right to antedate any such document, as by a showing under 35 C.F.R. § 1.131 or other method.

Please acknowledge receipt of this Information Disclosure Statement and kindly make the cited references of record in the above-identified application. The fee for submission of this Information Disclosure Statement under 37 CFR §1.97 may be charged to Deposit Account 50-0665.

Respectfully submitted,

Perkins Coie LLP



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Enclosures:

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Form PTO/SB/08A
Cited References (39)

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